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## I THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Tyler A. Lowrey

Art Unit:

2814 -

Serial No.:

09/944,478

Examiner:

Tuan N. Quach

Filed:

August 31, 2001

Docket:

ITO.0506US

P12499

For:

Elevated Pore Phase-

Change Memory

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Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO FINAL REJECTION

Sir:

In response to the final rejection mailed August 12, 2003, please amend the abovereferenced patent application as follows:

PLEASE

ENTER

THE

AMENDMENT

AFTER

FINAL

TU

10/1/07

Date of Deposit: A U Q U S + 2 L C C 3

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mall with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandriz, VA 22313-1450.

Cynthia L. Hayden